

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuaki KUWATA

Application No.: 10/691,503

Filed: October 24, 2003

For: SURFACE EMITTING SEMICONDUCTOR
LASER AND COMMUNICATION SYSTEM
USING THE SAME**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Group Art Unit: 2828

Examiner: P. NGUYEN

Docket No.: 117604

MAIL STOP RCECommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

Applicant further requests entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 191558 in the amount of \$790.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

James A. Oliff

Registration No. 27,075

Linda M. Saltiel

Registration No. 51,122

JAO:LMS:RAC/eks

Date: April 11, 2007

OLIFF & BERRIDGE, PLC
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 Alexandria, Virginia 22320
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DEPOSIT ACCOUNT USE AUTHORIZATION
Please grant any extension necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

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